

REMARKS

Claims 34-37, 39, and 41-53 are pending, with claims 34, 35, 46, 49, and 53 being independent.

Claims 34, 35, 39, 41-45, and 49-51 stand rejected under 35 U.S.C. § 102 (e) as being anticipated by Yamazaki et al. (6,384,427). With respect to independent claims 34 and 35, these claims have been amended to obviate this rejection. With respect to independent claim 49 and its respective dependent claims, Applicant respectfully traverses this rejection.

As amended, claims 34 and 35 recite a method of manufacturing a light emitting device that includes, among other features, making an atmosphere in the processing chamber contain a first solvent. Previously presented claim 49 recites a method of manufacturing a light emitting device that includes, among other features, making an atmosphere in the chamber contain a first solvent. Applicant respectfully requests reconsideration and withdrawal of the rejection because Yamazaki fails to describe or suggest a method of manufacturing a light emitting device that includes making an atmosphere in the chamber contain a first solvent.

Although, as noted in the Office Action, Yamazaki describes placing "an apparatus for forming the light-emitting layer in a clean booth filled with an inert gas and conduct the step of forming the light-emitting layer in the inert atmosphere" (col. 7, lines 8-19), Yamazaki fails to describe or suggest making the atmosphere in the chamber contain a first solvent.

For at least this reason, Applicants request removal of the § 102 (e) rejection of independent claims 34, 35, and 49, and their respective dependent claims.

Claims 34-37, 39, 41-48, 50, 52, and 53 stand rejected under 35 U.S.C. § 103(a) as being unpatentable over Porowski et al. (6,329,215) in view of Yamazaki et al. (6,384,427). With respect to independent claims 34, 35, and 46, Applicants have amended these claims to obviate the rejection. With respect to independent claim 53, Applicant respectfully traverses this rejection.

As amended, claims 34, 35, and 46 recite a method of manufacturing a light emitting device that includes, among other features, making an atmosphere in the processing chamber contain a first solvent. Previously presented claim 53 recites a method of manufacturing a light

emitting device that includes, among other features, making an atmosphere in the chamber contain a first solvent. Applicant respectfully requests reconsideration and withdrawal of the rejection because Porowski and Yamazaki, either alone or in combination, fail to describe or suggest a method of manufacturing a light emitting device that includes making an atmosphere in the chamber contain a first solvent.

As noted above, Yamazaki fails to describe or suggest the recited feature. Porowski fails to remedy the shortcomings of Yamazaki. Porowski is directed to metalorganic chemical vapor deposition (MOCVD) techniques for forming semiconductors for use in light emitting devices. However, Porowski fails to describe or suggest a method of manufacturing a light emitting device that includes making an atmosphere in the chamber contain a first solvent.

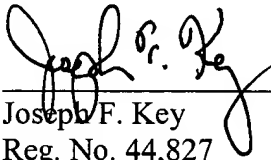
For at least this reason, Applicant respectfully requests withdrawal of the § 103 (a) rejection of independent claims 34, 35, 46, and 53, and their respective dependent claims.

All claims are believed to be in condition for allowance.

Enclosed is a \$880 check (\$770 for the Request for Continued Examination Fee and \$110 for the Petition for Extension of Time fee). Please apply any other charges or credits to deposit account 06-1050.

Respectfully submitted,

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